

<b>Notice of References Cited</b>			Application/Control No.	Applicant(s)/Patent Under Reexamination	
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Examiner			Art Unit	2617	Page 1 of 1
Michael Mapa					

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*	B	US-2003/0103487	06-2003	Kim et al.	370/350
*	C	US-2003/0012176	01-2003	Kondylis et al.	370/348
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